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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:** Warren M. Farnworth

**Serial No.:** 10/663,944

**Filed:** September 16, 2003

**For:** STEREOLITHOGRAPHIC METHOD  
FOR FORMING INSULATIVE COATINGS  
FOR VIA HOLES IN SEMICONDUCTOR  
DEVICES, INSULATIVE COATINGS SO  
FORMED, SYSTEMS FOR FORMING THE  
INSULATIVE COATINGS, AND  
SEMICONDUCTOR DEVICES  
INCLUDING VIA HOLES WITH THE  
INSULATIVE COATINGS

**Confirmation No.:** 3861

**Examiner:** William M. Brewster

**Group Art Unit:** 2826

**Attorney Docket No.:** 2269-5700US  
(02-1183.00/US)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 9, 2004  
Date

Signature

Denise Dyer  
Name (Type/Print)

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed on August 9, 2004, the three-month shortened statutory period for response to which expires on November 9, 2004.

**Amendments to the claims** are set forth in the listing of the claims, which begins on page 2 of this paper; and

**Remarks** start at page 9 of this paper.